### TEM-

# the Transmission Electron Microscopy,

a Powerful Tool for Imaging, Diffraction and Spectroscopy in Materials Science

### Lecture -- I

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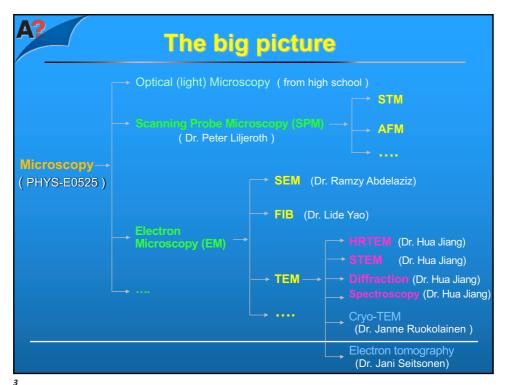
# **A?**

# A quick review of last two lessons

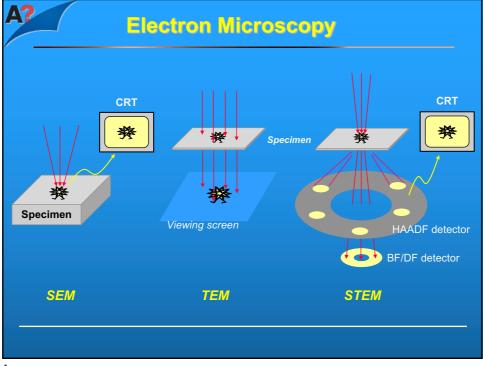
Let's review what have impressed you the most by far:

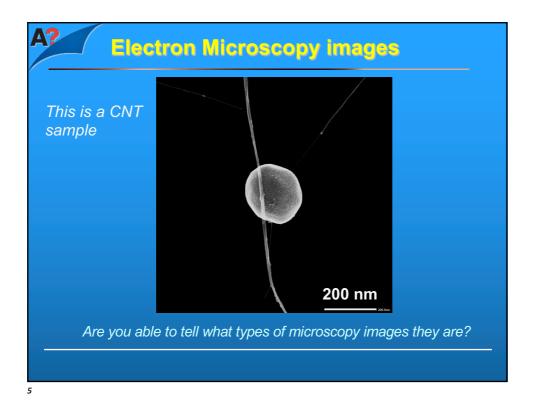
- · What is this course (PHYS-E0525) about?
  - Keywords: Microscopy of Nanomaterials
- · What is "Microscopy" about ?
  - Keywords: Optical (light); SPM (STM, AFM); EM; ..
- What is "Electron Microscopy" about ?
  - Keywords: SEM: FIB: TEM: STEM: Tomography...
- · How does "Electron Microscopy" work?

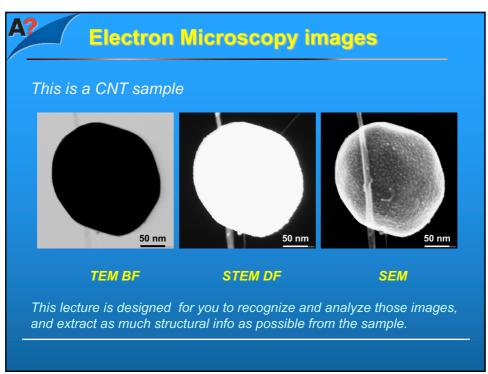
**Keywords:** electron microscopes; guns, lens, aperture aberrations, vacuum, camera / detectors....

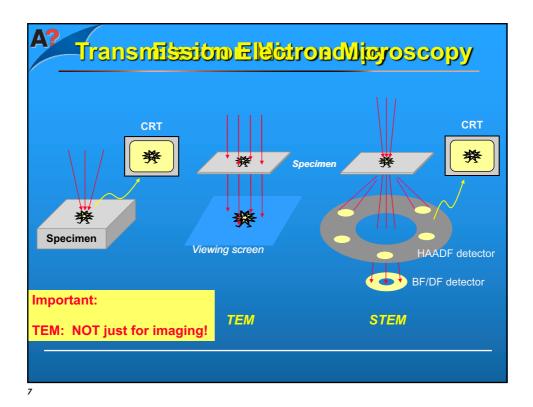


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Cutline of the lectures

TEM basics – a brief overview
- why we use electrons for microscope?
- why it is possible to use electrons?
- How to use electrons: electron-sample interactions
- basics of the instrument
- sample requirements and preparation
- what to learn from this lecture

Diffraction in TEM

Imaging in TEM

STEM imaging

Spectroscopy in TEM

Lect. 3
Feb. 14

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# TEM Basics --- a quick review

- Basics of the TEM instrument --- the Microscope
- Electrons and their interaction with samples
- TEM sample preparation
- Electron microscopy of a number of aspects

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# Why electrons

$$d = \frac{0.61\lambda}{n\sin\alpha} \cong \frac{1}{2}\lambda$$

d --- resolution;  $\lambda$  --- light wavelength

 $n \sin \alpha$ : may be as large as 1.3 (Numerical Aperture or N.A.)  $\lambda$  as short as 400nm

<u>In brief:</u> the resolution limit of a light microscope (LM) cannot be better than 200 nm, far away from seeing the nano-world.

# Why electrons

- nature of electrons
- - Moving electrons are electron wave

$$\lambda = \frac{h}{m_e v} \quad \propto \quad \frac{1}{v}$$

v --- speed; h --- Planck constant; me --- mass

The higher electron energy, the shorter electron wavelength

$$\lambda = \frac{12.25}{\sqrt{U(1+0.9788 \cdot 10^{-6} U)}} \quad \propto \quad \frac{1}{\sqrt{U}}$$

U --- accelerating voltage

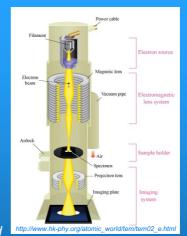
80kV: 0.00418nm 120 kV: 0.00335nm 200 kV: 0.00251nm

300 kV: 0.00197nm

In brief: resolution supposed to be improved by using electron to image.

### The basic units in an electron microscope

- Electron gun
  - --- a source for producing high energy electrons
- Electron lens
  - --- a medium for deflecting or focusing electrons
- Cameras / Detectors
- High vacuum
  - --- an environment that frees the interaction of electrons from anything else but your sample and the lenses.



In brief: using electron as illumination source is not just

beneficial but also possible.

### **Electron Gun**

### Function

--- providing electron illumination at high current in a small probe size

### Configuations

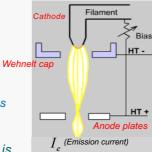
- --- a scheme of a typical thermionicemission gun (right)
  - Cathode: the filament
  - · Anode plates: accelerating electrons

### Accelerating voltage (U)

--- the electron energy (wavelength) is given by the accelerating voltage

### <sup>☞</sup> Emmision current (I<sub>e</sub>)

--- the total current leaving the gun, typically ~100 μA





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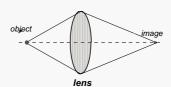
# **Electron Lens**

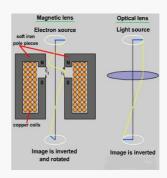
### Function

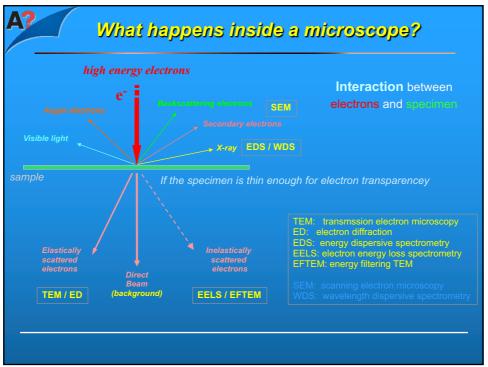
- --- a lens forms an image of an object
- an optical microscope uses glass to refract light and form images.
- The electron beam is focused using electromagnetic lenses, which employ magnetic or electrostatic fields as the refracting medium.

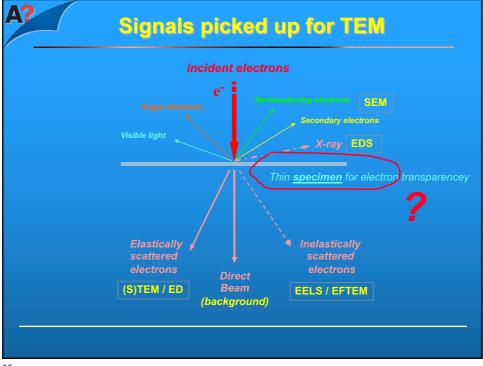
### Magnetic lens

- --- including bacially lens coil which produce the magnetic field.
- --- the focal length **f** can be changed by varying the lens excitation (the current or the potential)











# Good specimen for TEM research

### **General requirements ??**

Be small: 3mm in diameter

Be thin: <100 nm in thickness

Remember: Your microscope (TEM) is only as good as the sample that you put into it !!!

\* 1 nm = 10<sup>-9</sup> meter 1 nm = 10 Å

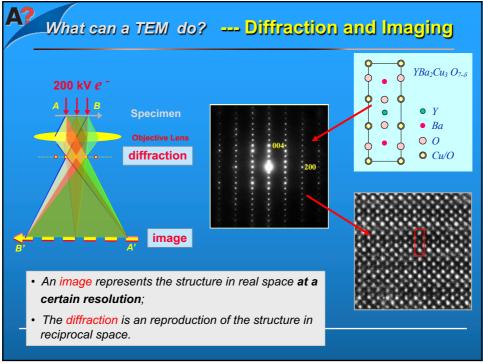
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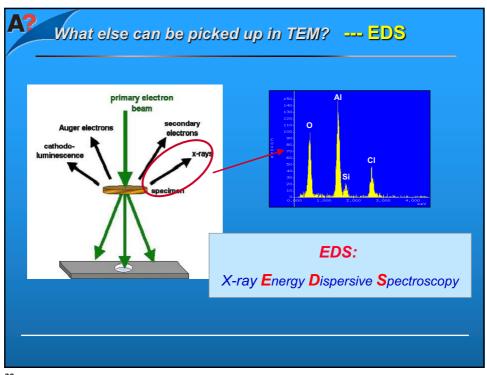
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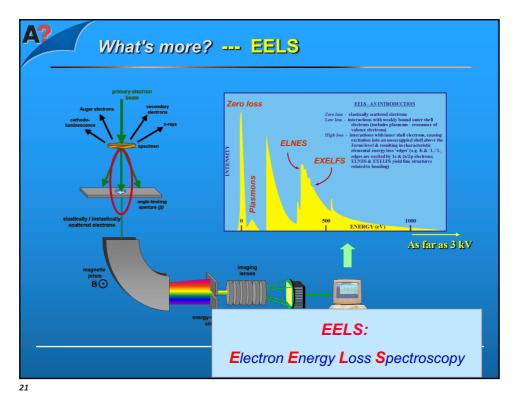
### TEM sample preparation

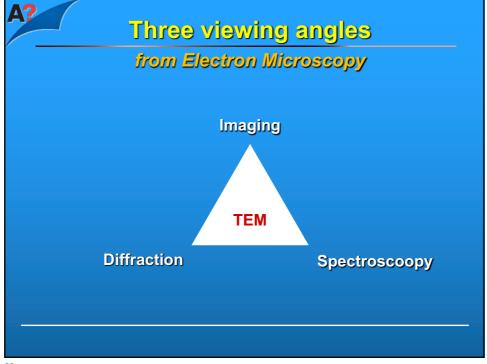
General rule: the thinner, the better, for "Electron transparency"

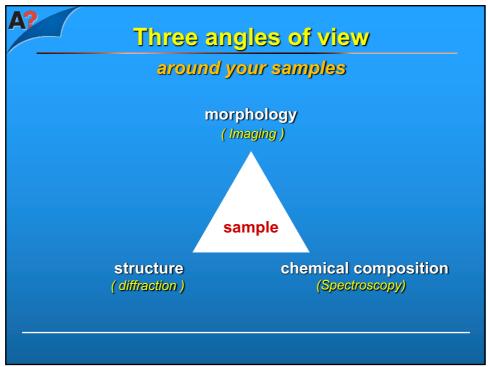
- Basic requirements
  - diameter φ ~ 3 mm
  - thickness t < 100 150 nm, < ~ 50 nm for HREM and spectrum
- Ways out: highly depend on the materials you are working on
  - powders, nanoparticles: direct TEM sample is possible
  - ion-milling: a sputtering method by kicking out atoms from the surface of the specimen by bombing with accelerated ions, such as Ar ions. Better for ceramics, semiconductor in particular.
  - FIB (Focus ion beam): originally developed for semiconductor devices. The specimen is thinned rapidly by sputtering with a sharply focused ion beam, such as Ga ions. Especially suitable for specimens containing a boundary between materials. A SEM image can be displayed while thinning.

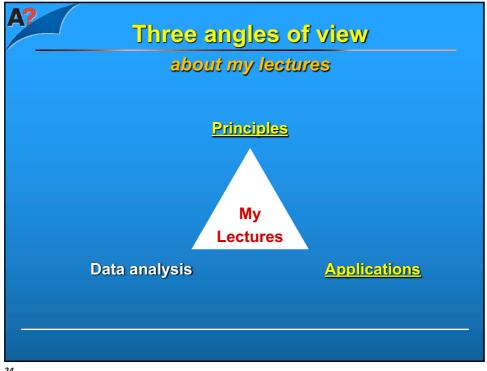














# What are you expected to learn from this lecture?

Be aware of:

What is TEM about in general?

Be capable of:

planning your experiments and working out your ideas by using TEM techniques!!

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# "Diffraction" in TEM

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# "Diffraction" in TEM

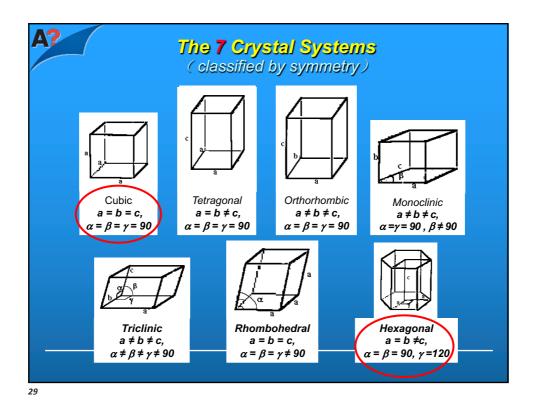
- Basic crystallography concept
- Diffraction <u>principles</u>
  - diffraction direction
  - diffraction intensity
- Application Examples
  - Structure analysis of SWCNTs
  - Oxygen behavior in YBCO

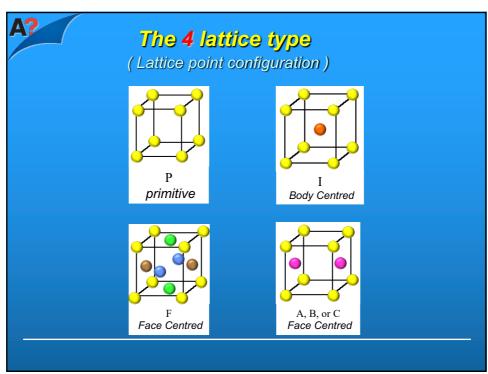
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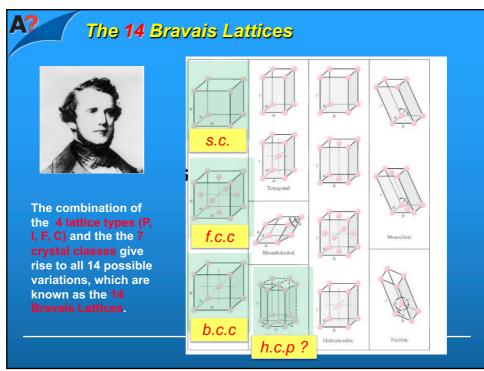
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# Basic crystallography

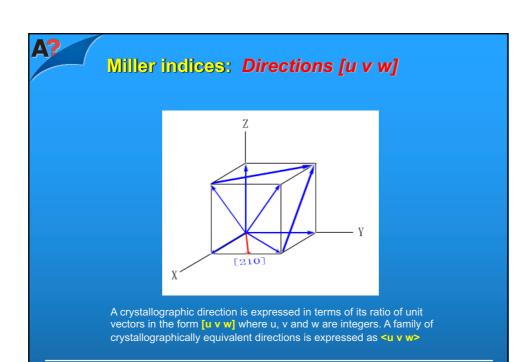
for a basic understanding of diffraction principle



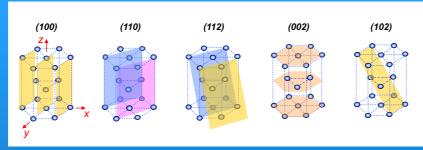




# Miller indices: Directions [u v w] Grouping symbols: () are called parentheses or rounded brackets; [] are called brackets or square brackets; {} are called braces or curly brackets; ⟨⟩ are called bra and ket or angular brackets. A crystallographic direction is expressed in terms of its ratio of unit vectors in the form [u v w] where u, v and w are integers. A family of crystallographically equivalent directions is expressed as <u v w>

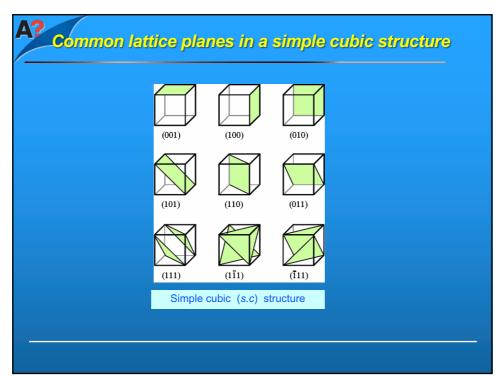


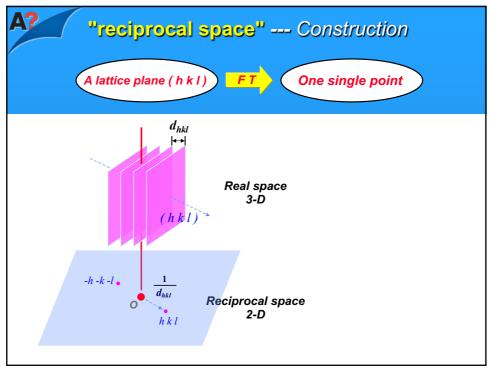
# Miller Indices: Lattice planes (h k l)

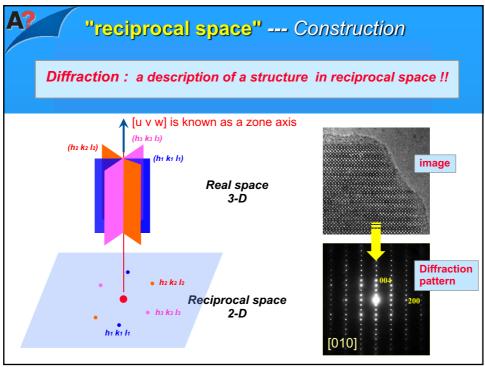


- In a crystal, there are numerous sets of lattice planes which are characterized by their 1) <u>orientations</u> and 2) <u>lattice spacings</u>.
- A set of lattice plane is labelled by using its *Miller Indices ( h k l )*.
- Electron beam is diffracted by lattice planes in a crystal structure.

A lattice structure is thus composed of a number of sets of lattice planes. (or say, a crystal structure can be decomposed into many lattice planes of...)









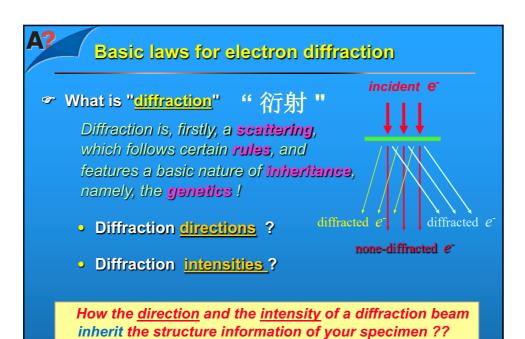


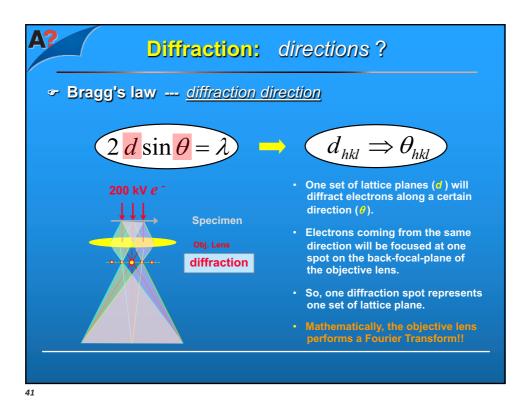
# **Electron Diffraction in TEM**

### Principles and applications

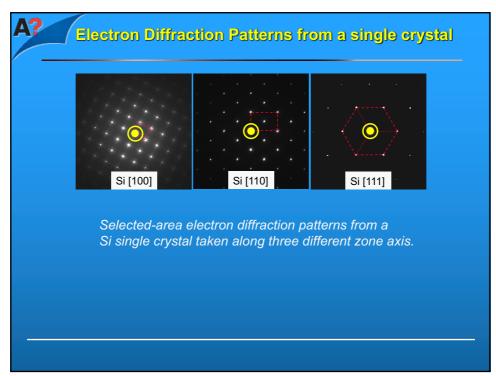
Transmission electron microscopes create magnified images of samples and are, in contrast to the <u>light microscope</u>, even able to resolve individual atoms. When transmitting a beam of electrons through a crystalline sample such as a complex mineral or a crystallized protein, the electrons are being diffracted in a specific way. Collecting such diffraction patterns of a sample from several different directions uniquely identifies a specific crystal structure.

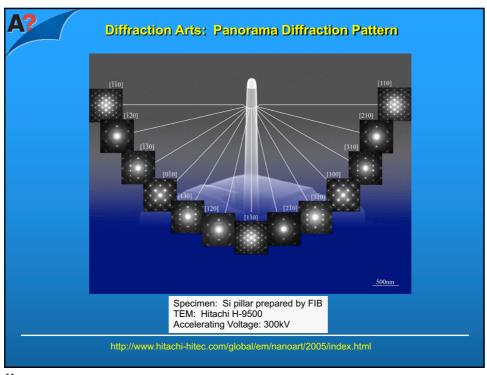
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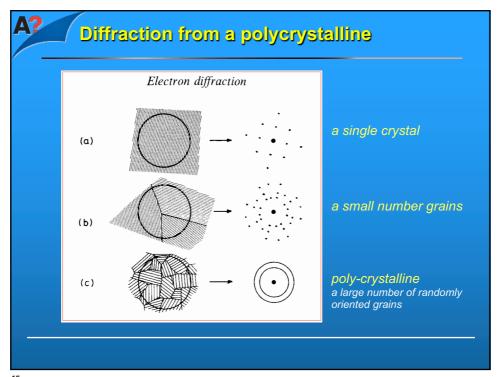


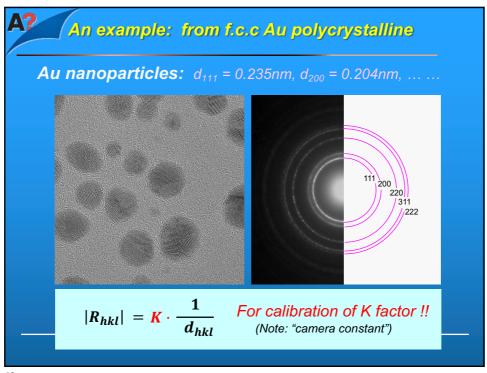


200 kV e<sup>-</sup>
specimen plane
Obj. Lens
diffraction pattern (1st FT)











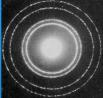
# Learn to be an expert to recognize things!

The following four EDPs are taken from Au, Cu, Al and  $\alpha$ -Fe polycrystalline respectively. Au, Cu and Al have f.c.c structure but  $\alpha$ -Fe has b.c.c structure. Their lattice constants are given: a(Au)=0.408nm, a(Cu)=0.361nm, a(Al)=0.405nm,  $a(\alpha$ -Fe)=0.286nm.









### **Questions:**

- 1. Can you recognize the EDP from b.c.c  $\alpha$ -Fe structure simply by a quick glance of those patterns? .
- 2. How would you distinguish EDPs from f.c.c Au, Cu and Al?
- 3. What other information would you need to answer Question 2?

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See you next Tuesday....